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OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Case No. 213.002-D1-US)

In the Application of: Ye et al.

Serial No: 10/646,313

Filed: August 22, 2003

Title: System and Method for Lithography

Process Monitoring and Control

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Group Art Unit: 2878

Before Examiner: Que Tan Le

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office,

Fax No. (571) 273-2438 on hay 11 2004

Date

(name of person signing-this certificate)

Signature

AMENDMENT

Dear Sir:

Kindly amend the above-referenced application as follows: